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Applicant(s): Finarov, Moshe

Assignee: Nova Measuring Instruments

Title: APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING POLISHING

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San Jose, California
July 29, 1999

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ASSISTANT COMMISSIONER FOR PATENTS
Washington, D. C. 20231

PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicant respectfully petitions for a one-month extension of time within which to file the formal drawings for the above-identified application, such extension allowing the undersigned until August 27, 1999 to submit the drawings.

Please charge our Deposit Account No. 19-2386 in the amount of \$ 55.00 as set forth in the enclosed transmittal letter.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: ASSISTANT COMMISSIONER FOR PATENTS, Washington, D.C. 20231, on July 29 1999.

David W. Heid

Attorney for Applicant(s)

7/29/99

Date of Signature

Respectfully submitted,

David W. Heid

David W. Heid
Attorney for Applicant(s)
Reg. No. 25,875

LAW OFFICES OF
SKJERVEN, MORRILL,
MacPHERSON, FRANKLIN
& FRIEL LLP

25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979

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